



1751
JFW

PATENT
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Applicants:

Bietsch, et al.

Serial No.: 10/081,860

Filed: February 22, 2002

For: *SELECTIVE ETCHING OF SUBSTRATES WITH CONTROL OF THE ETCH PROFILE*

Date: January 17, 2005

Group Art Unit: 1751

Examiner: Lynette T Umez Eronini

Docket No.: CH920010003US1

Assistant Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

IN THE DRAWINGS:

Please review and enter the enclosed six sheets of formal drawings into the above-identified application.

Respectfully Submitted,

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I hereby certify that this paper is being deposited with the United States Postal Service, first class mail, postage prepaid, on the date indicated below in an envelope addressed to the Commissioner of Patents and Trademarks, Post Office Box 1450, Alexandria, VA 22313-1450

Signature

Thomas A. Beck

Date: January 25, 2005